

Article

Metal Foam Electrode as a Cathode for Copper Electrowinning

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Abstract: The geometry of porous materials is complex, and the determination of the true surface area is important because it affects current density, how certain reactions will progress, their rates, etc. In this work, we have investigated the dependence of the electrochemical deposition of copper coatings on the geometry of the copper substrate (flat plates or 3D foams). Chronoamperometric measurements show that copper deposition occurs 3 times faster on copper foams than on a flat electrode with the same geometric area in the same potential range, making metal foams great electrodes for electrowinning. Using electrochemical impedance spectroscopy (EIS), the mechanism of copper deposition was determined at various concentrations and potentials, and the capacities of the double electric layer (DL) for both types of electrodes were calculated. The DL capacity on the foam electrodes is up to 14 times higher than that on the plates. From EIS data, it was determined that the charge transfer resistance on the Cu foam electrode is 1.5–1.7 times lower than that on the Cu plate electrode. Therefore, metal foam electrodes are great candidates to be used for processes that are controlled by activation polarization or by the adsorption of intermediate compounds (heterogeneous catalysis) and processes occurring on the entire surface of the electrode.

Keywords: metal foam; surface area; electrowinning; Cu electrodeposition; EIS; double electric layer capacitance

1. Introduction

The ever-increasing need for electronics, especially, handheld and portable electronics, and the need to reduce their size and increase their efficiency, generates a lot of various electronics waste all over the globe [1–3]. There are many ways to reclaim used metals in electronic waste; however, electrowinning is a very efficient and quite selective process allowing the recovery of high amounts of various pure metals [4–6]. Metallic foams and porous electrodes have an outstanding potential to be used as a cathode to collect deposited metals because of the functionality of their combined material properties resulting from their specific morphology. There already is great interest in the synthesis of various porous materials such as metal foams, nanowires, porous coatings, thin porous films, etc. [7–15]. Depending on the materials, type of pores (open or closed cells), the porosity and size of pores, such materials have broad application capabilities, from simple ones such as heat transfer or electrodes to more complicated cases of various redox reactions, catalysis, sensing, supercapacitors, or even gas storage because of the high surface area and low density available [9,16–29].

Any solid metal surface that acts as a substrate for electrochemical reactions possesses a certain roughness that can affect in different ways the values of the limiting diffusion current and the exchange current density. On the other hand, if the surface coarseness is relatively small, the limiting diffusion current density does not depend on the surface roughness, and it can be only correlated to the apparent

surface of the electrodes. If the surface roughness of electrodes increases, the effective values of the exchange current density are also increased for the process under consideration, which is standardized to the apparent electrode surface area. At the same time, the limiting diffusion current density depends on the surface coarseness due to the decrease of the effective value of the diffusion layer thickness. If the level of the electrode surface coarseness remains low, the change of the limiting diffusion current density can be neglected [30]. In addition, it has been shown that when the metal deposition is controlled by diffusion (particularly silver), the surface with the highest surface roughness had a lower number of active sites but higher deposition efficiency and a higher efficiency of charge transfer [31]. The dependence between surface roughness and deposition efficiency is non-linear; the surface roughness needs to be quite high to affect the deposition efficiency [31,32]. It was proven that when the deposition reaction is controlled by the diffusion, the geometry of the electrode has no significant influence on the reaction [33]. Using very porous or surfaces with high roughness, one can eliminate activation and diffusion overpotentials, making the reaction process controlled by Ohmic effects and thus making the reaction much faster [30,31]. All these effects make porous metal electrodes with pore diameters higher than 50 μm high-performance cathodes for deposition reactions under diffusion control.

The estimation of the active surface area of highly porous conducting materials is also very important. Thus, various in situ or ex situ techniques can be used for these purposes. In situ techniques are preferred, since drying the sample can cause changes in the surface area and/or oxidation of the surface, changing its characteristics. Depending on the material and its porosity, one can use techniques for double electric layer estimations (cyclic voltammetry, initial charge-up dependencies, electrochemical impedance spectroscopy (EIS)), or adapt various adsorption/redox reactions that occur on the surface (underpotential depositions, adsorption measurements, reduction of various dyes, etc.) [29,34–39]. The classical techniques for surface area estimation—liquid permeability, gas adsorption (Brunauer–Emmett–Teller technique)—in some cases can also be used [34,35,39]. However, these techniques require higher amounts of materials and can have quite large error margins, depending on the geometry of the pores and the sample itself. For porous materials that are quite level, and with ordered pores, more sophisticated techniques could be used for porosity estimation such as atomic force microscopy (AFM) or spectroscopic ellipsometry; the latter requires a rather complex modeling [40–42].

EIS is a very powerful and versatile in situ technique that allows not only estimating the true surface area of conducting materials but also investigating the surface and the processes happening at the surface [9,20,23,27,29]. Using the EIS technique, one can investigate both Faradaic and non-Faradaic processes on the surface simultaneously [27,29,34,35,43–47]. Even the size and distribution of the pores can be characterized by employing the EIS technique [45,46]. However, the surface area determined by EIS or any other electrochemical method is not the true surface area, but rather the electrochemically active surface area, which can be much more useful when trying to determine the activity of porous materials for a hydrogen evolution reaction (HER) or other electrochemical reaction [39–47].

In this work, we investigated the deposition of copper on the plate (2D) and foam (3D) copper substrates using voltammetry and EIS. The comparison of 2D and 3D electrodes has been carried out to determine differences in double electric layer formation, charge transfer, diffusion, and deposition rates. These results are important for trying to enhance the potential application of foam electrodes in industry, and particularly for the electrowinning of copper from electronics waste.

2. Materials and Methods

2.1. Materials and Sample Preparation

All of the chemicals used for analysis were of analytical grade (Carl Roth, Karlsruhe, Germany). Solutions have been prepared using deionized water (DI). Solution compositions used for electrochemical experiments are shown in Table 1. The pH of solutions was adjusted using sulfuric acid and controlled by a benchtop pH-meter ProLine Plus (Prosence B.V., Oosterhout, The Netherlands).

Cu plates and Cu foam electrodes served as working electrodes. The Cu foam sheets used to fabricate electrodes were purchased from Alfa Aesar. To characterize commercially available copper foams, we have done some experiments trying to determine the basic characteristics of this foam. Foam density has been determined as gravimetrically being equal to 0.748 g/cm^3 , making the porosity of the foam to be around 90.5%. The copper foam has a 3D interconnected porous structure, which can be observed in SEM images (Figure 1). The pore size varies from 1 to 0.1 mm. The surface of the foam is very uneven, making the true surface area of the already porous copper foam even larger.

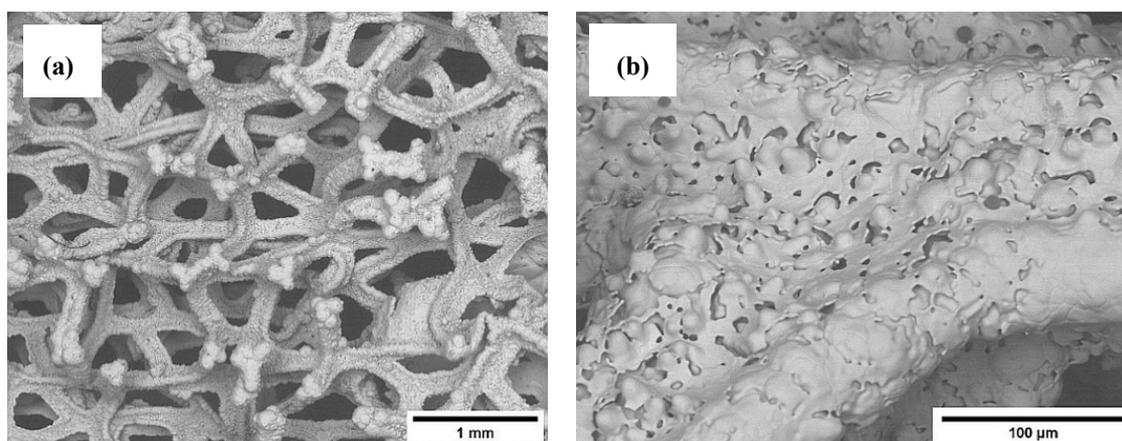


Figure 1. SEM images at low (a) and high (b) magnification of 3D copper foam.

Working electrodes (copper plates and copper foams) have been washed and degreased using acetone, ethanol, and water in succession and in combination with ultrasonic bath. Both flat and porous samples were $1 \text{ cm} \times 1 \text{ cm}$ in geometrical size with both sides conducting. To ensure that the working surface was that of the desired size, other parts of the samples were isolated using insulating plastic spray (PRF 202, Taerosol Oy, Kangasala, Finland). Just before measurements, the native copper oxide layer has been removed by dipping copper samples into $2 \text{ M H}_2\text{SO}_4$ solution for 2 s and afterward rinsing with DI water.

Table 1. Composition of solutions used for electrochemical measurements.

$c(\text{CuSO}_4)$, M	$c(\text{Na}_2\text{SO}_4)$, M	pH
0.01	0.49	3.6
0.05	0.45	3.6
0.1	0.4	3.7
0.2	0.3	4.1

2.2. Instrumentation and Methodology

Morphology: The morphology of copper foams has been investigated using a scanning electron microscope (SEM, Hitachi's Tabletop Microscope TM-3000, Tokyo, Japan).

Electrochemical Measurements: Electrochemical measurements (voltammetry, EIS, chronoamperometry, etc.) have been performed using programmable potentiostat/galvanostat AUTOLAB PGSTAT 302N (Metrohm, Utrecht, The Netherlands). The software used for controlling the hardware was Nova 1.11.2.

Conditions of Electrochemical Measurements: A three-electrode system was used for all the electrochemical experiments, where Cu plates or Cu foams were used as working electrodes, circular platinized titanium mesh (Alfa Aesar, Ward Hill, MA, USA) was used as a counter electrode, and Ag/AgCl filled with saturated KCl solution (Sigma-Aldrich, St. Louis, MO, USA) was used as a reference electrode. The distance between the counter and working electrode was fixed at 2.5 cm. All

electrochemical experiments have been performed at room temperature. Voltammetry measurements were done using the potential sweep voltammetry technique on Cu plates and Cu foams as working electrodes, starting at open circuit potential and going up to -1.2 V versus Ag/AgCl at a 2 mV/s scan rate. Voltammetry measurements have been performed using all the solutions shown in Table 1. Chronoamperometry experiments were performed at 4 distinct potentials (-0.1 , -0.2 , -0.4 and -0.6 V versus Ag/AgCl) using different substrates as working electrodes (Cu plates or foams) in 0.1 M CuSO_4 and 0.4 M Na_2SO_4 solution. The same amount of electric charge was used to deposit coatings, i.e., 30 C. The current efficiency was calculated using chronoamperometry data and change in substrate mass after deposition.

Electrochemical Impedance Spectroscopy (EIS): Electrochemical impedance spectroscopy (EIS) measurements have been done using a standard three-electrode system, carried out in a frequency range of 10 kHz to 0.1 Hz, using perturbation amplitude of 10 mV. Obtained data were fitted to the equivalent electric circuit model (EEC) using ZView 2.8d software.

3. Results and Discussion

3.1. Copper Foam Characterization

In order to determine how the behavior of copper foams differs from flat surfaces in solutions, voltammetry experiments with different copper sulfate concentrations were carried out; the compositions of the solutions are shown in Table 1. The concentration of the sulfate anion was kept at 0.5 M to maintain the same buffering power in all of the solutions. The obtained polarization curves for the plate and foam electrode are shown in Figure 2, where the ordinate axis is displayed in a logarithmic scale because of a big difference in the current values between tested concentrations. To estimate the influence of porosity on the copper deposition, the geometrical sample size was the same for both Cu plates and Cu foams (1 cm \times 1 cm). As can be seen from Figure 2, Cu deposition starts somewhere around -0.075 V versus Ag/AgCl and did not depend on the substrate used. After the peak representing the Cu^{2+} reduction to Cu^0 , the current on both surfaces and all the concentrations turns into an almost constant one. The reason for this could be the mass transport limitations because the leveling off of the current depends on the concentration of Cu(II) in the solution. This is also supported by the slight increase of the current with the rise of polarization at higher concentrations (50 mM to 0.2 M), showing that with higher potential, the positive ions are attracted from further away, and the deposition rate increases.

In addition, voltammetry tests also showed that independently of the substrate used, the hydrogen evolution reaction (HER) started in the range of -1.0 to -1.1 V versus Ag/AgCl in the solutions containing 10 and 50 mM of CuSO_4 . This fact could be attributed to the governing role of pH change in the pre-electrode layer during electrodeposition, and this change seems to be similar for both solutions. However, in the solution containing 0.2 M CuSO_4 , the HER started around -0.75 V versus Ag/AgCl on both surfaces. It can be linked to the higher rate of copper electrodeposition, and in turn, the pH decrease near the working electrode. Thus, the major difference between the two surfaces can be noted from voltammetry experiments: there was an approximately 3 times higher current on the foam substrate at all potentials in comparison to the flat surface. This difference can be explained by the better hydrodynamic conditions of copper foams substrate: the porous surface allows for faster mass transport and exchange.

For further investigation, the solution containing a similar amount of Cu(II) as in solutions used for the metals recovery from the electronic waste was chosen. Regarding the influence of the surface type on the Cu electrochemical deposition, chronoamperometric measurements have been done in 0.1 M CuSO_4 and 0.4 M Na_2SO_4 solution at four fixed potentials: -0.1 , -0.2 , -0.4 , and -0.6 V versus Ag/AgCl, and at a fixed amount of charge passed through the cell (30 C). The results have been summarized and are shown in Table 2.

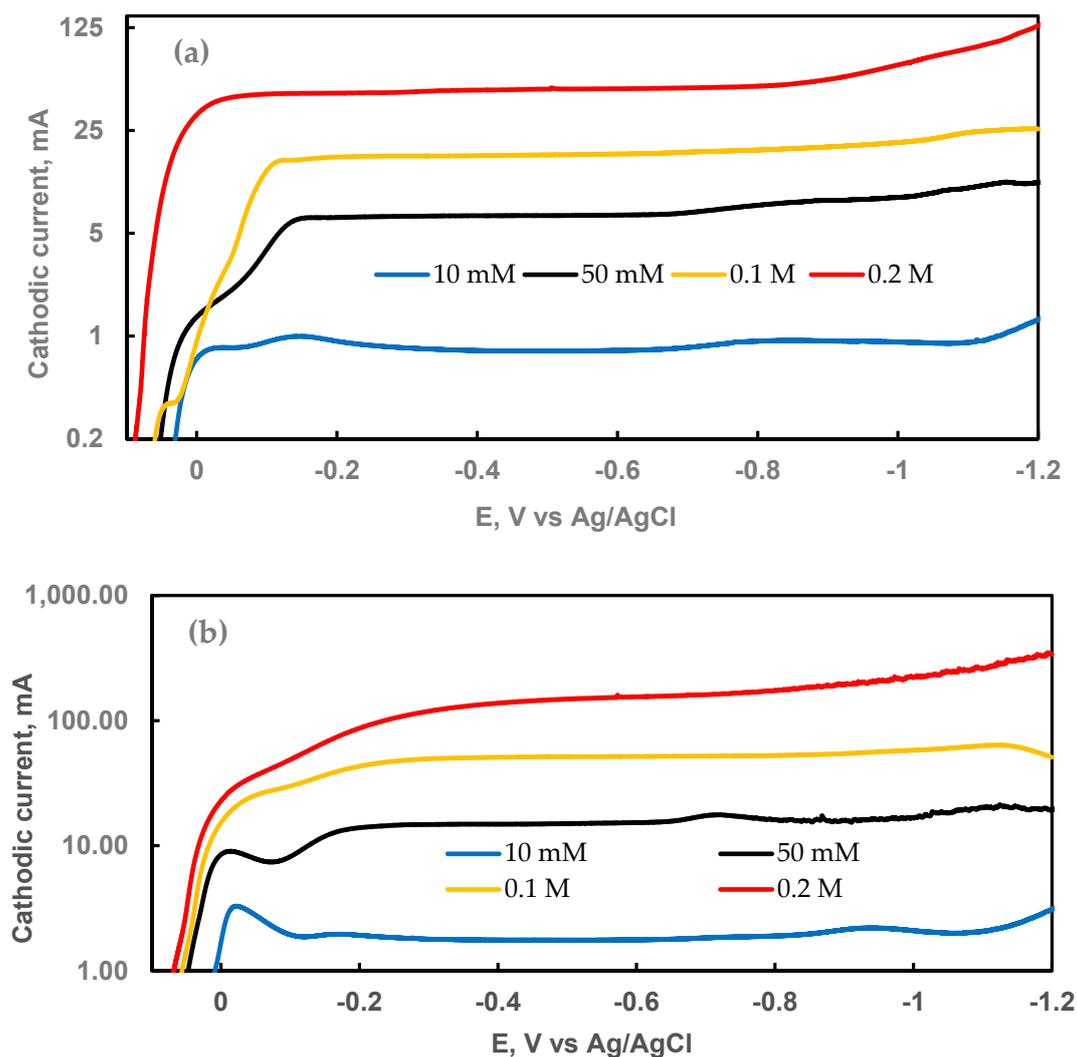


Figure 2. Cathodic voltammograms on Cu plate (a) and foam (b) obtained in the electrolytes with various concentrations of CuSO₄ (the compositions of solutions are shown in Table 1), potential scan rate 2 mV/s.

Table 2. Cu deposition rates on 2D and 3D electrodes in the solution containing 0.1 M CuSO₄ and 0.4 M Na₂SO₄.

Cu Plate			Cu Foam		
E, V versus Ag/AgCl	Deposition Time (s)	Cu Deposition Rate (mg/min)	E, V versus Ag/AgCl	Deposition Time (s)	Cu Deposition Rate (mg/min)
-0.1	1763	0.33	-0.1	643	0.94
-0.2	1681	0.35	-0.2	574	1.1
-0.4	1603	0.36	-0.4	593	1.0
-0.6	1571	0.37	-0.6	518	1.2

Chronoamperometric measurements (Table 2) clearly show an approximately 3 times faster copper deposition rate on the foam at all tested potentials. In this case, there was no hydrogen evolution, and the deposition efficiency was almost 100% on both substrates. A considerably higher deposition rate on the copper foam substrate supports the idea that the deposition is controlled by diffusion to the electrode having a higher specific surface area. In addition, a higher metal deposition rate on the foam electrodes makes them an attractive substrate for the electro-winning of metals compared to other

materials having a similar geometric area. The morphology of deposits is influenced by the potential and type of substrate, as it is shown in the SEM images in Figure 3.

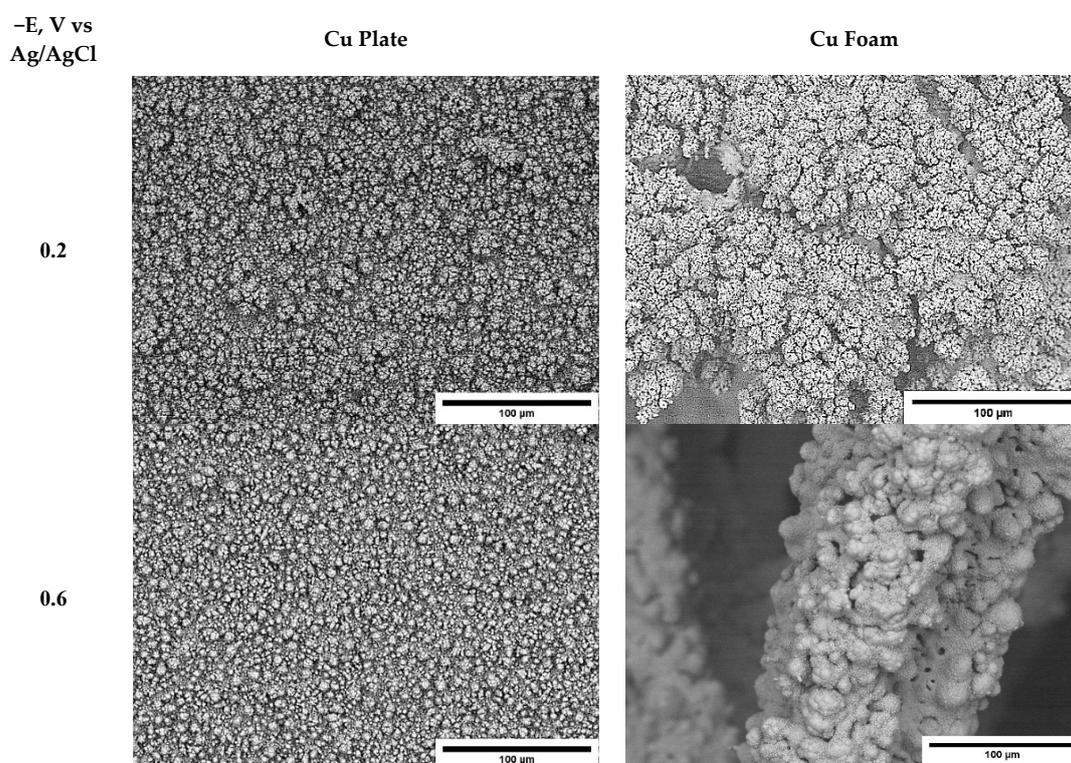


Figure 3. SEM images of potentiostatically electrodeposited Cu coatings at different cathodic potentials on flat and foam copper substrates after 30 C passed charge. The bath was 0.1 M CuSO_4 and 0.4 M Na_2SO_4 .

The copper deposits have globules shapes on the flat electrodes, and the morphology did not differ at these two potentials. This is related to the very similar electrochemical deposition rates at these potentials, and as it can be seen from the voltammetry data (Figure 2) and efficiency of deposition, there were no side reactions, and the current was similar at these two potentials. Another case is the deposition on the porous substrate. At -0.2 V versus Ag/AgCl, copper forms cauliflower-like crystalline agglomerates with well-defined edges. At higher potential, the copper forms smoother surfaces that are still cauliflower-like structures. The coverage of both surface geometries was good even without external agitation, even at low potentials.

3.2. Surface Area and Diffusion Rate Estimations

To characterize copper foams and estimate the active surface areas for the charge and mass transfer processes that occur during the electrochemical deposition of copper, we utilized the EIS technique. EIS measurements have been done for all the solutions listed in Table 1. EIS measurements were performed at cathodic potentials of -0.125 , -0.15 , -0.175 , and -0.2 V versus Ag/AgCl on flat and porous copper substrates. These potentials were chosen based on chronoamperometric data. At such low potentials, the change of surface morphology during deposition is still minimal and can be ignored in this case. Typical EIS scans on the copper plate at various potentials are shown in Figure 4. From the EIS data plots, we can see that at investigated potentials, the data plot can be divided into two zones: the high-frequency semicircle and the low-frequency (starting around 75–100 Hz) 45° angle line. The high-frequency semicircle can be attributed to charge up of the double layer and charge transfer to the copper ions, whilst the low-frequency line is attributed to the formation of the concentration gradient of the copper ions. To better evaluate ongoing processes, EIS data were fitted to the equivalent electric

circuit (EEC) that is shown as an inset in Figure 4 of the Nyquist plot (a). The elements of applied EEC have the following physical meaning: R_0 is resistance at the electrode/electrolyte interface, CPE(DL) is a double-layer capacitance modeled via the constant phase element (CPE), $R_{(CT)}$ is a charge transfer resistance, CPE(W) stands for the capacitance caused by the concentration gradient, and $R_{(Diff)}$ is a resistance caused by the concentration gradient. The element CPE(W) is attributed to the diffusion because of the signature 45° angle seen in the Nyquist plots at low frequencies (Figure 4), and the value n in this CPE element was very close to 0.5 in all the experiments. This constant phase element acting only in the low-frequency region represents diffusion, and it can be used as a Warburg element when $n = 0.5$ [48,49]. The values of the constant phase element CPE(DL) have been recalculated into true capacitance using Hsu and Mansfeld’s equation [50]. All values of components of the fitted EEC are indicated in Table 3.

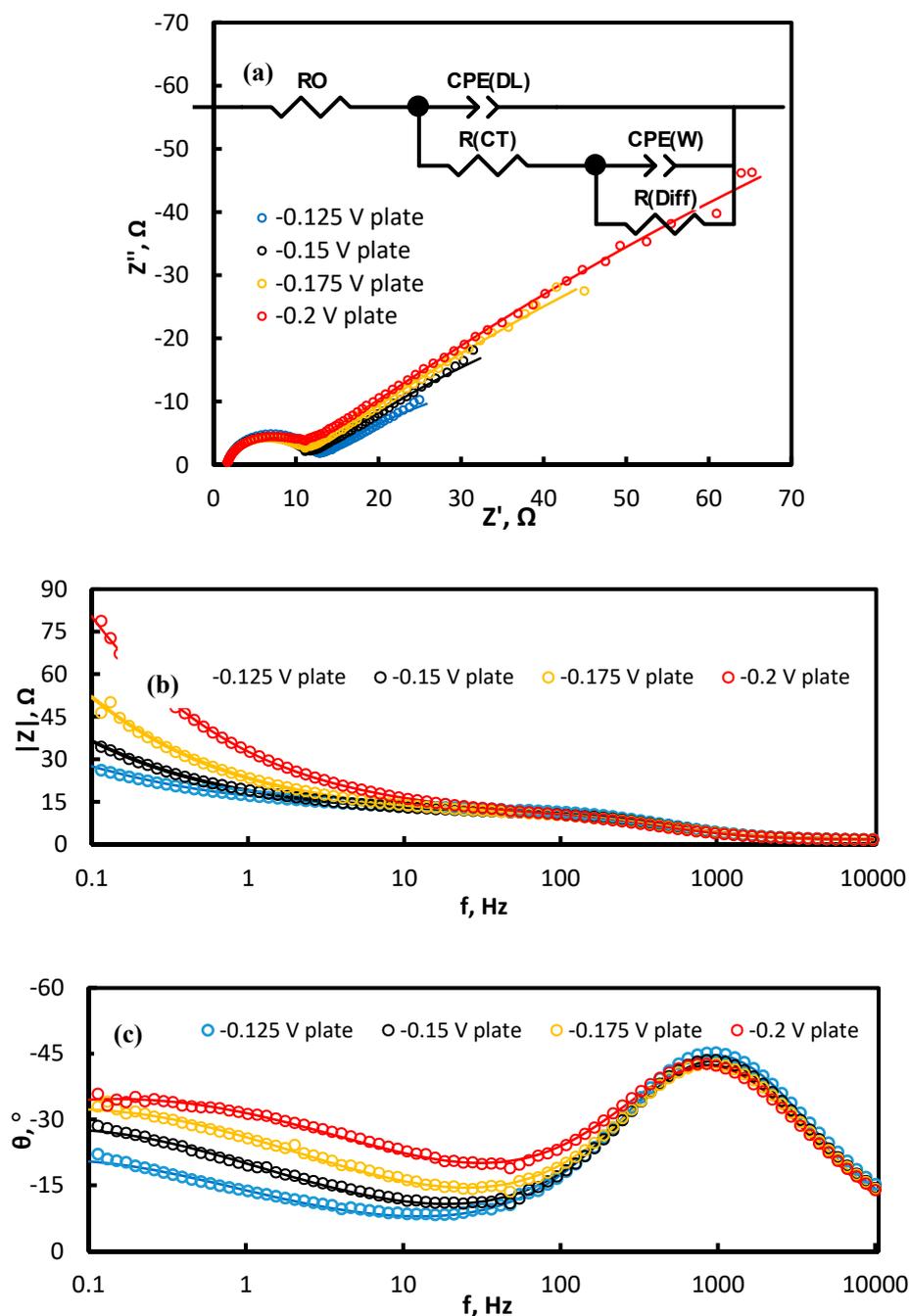


Figure 4. Cont.

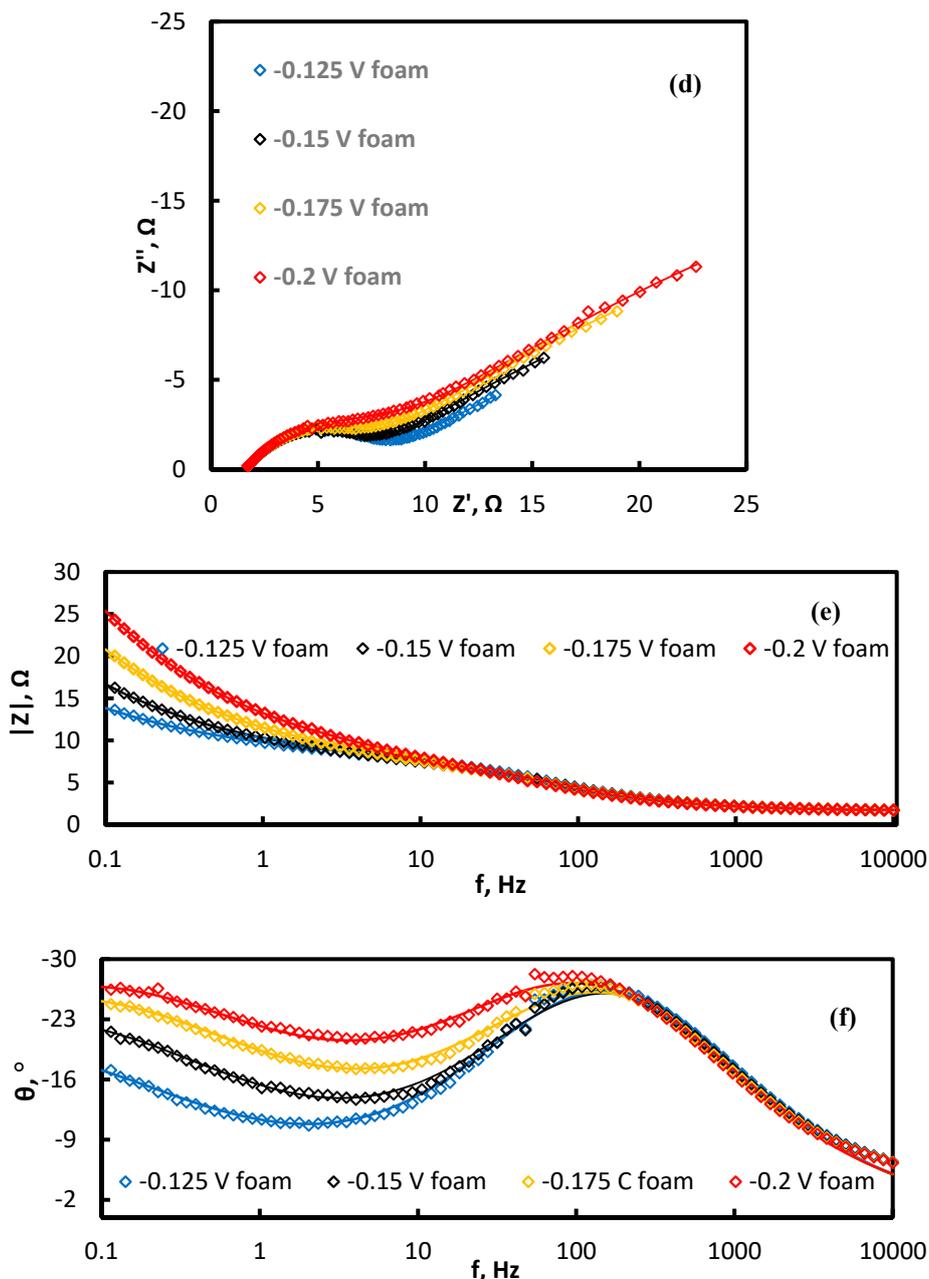


Figure 4. Nyquist (a,d) and Bode plots (b–c,e–f) on Cu plate (a–c) and foam (d–f) registered at various potentials (indicated on graphs) in 0.1 M CuSO_4 + 0.4 M Na_2SO_4 solution at 20 °C. Points—experimental data, solid lines—results of fitting to equivalent electric circuit (EEC) shown in the inset (a).

As it is seen, the proposed EEC describes well experimental EIS data on both substrates in a whole investigated potential range. The values of the capacitance of the double electric layer on both substrates might be used to estimate differences in real areas between the plate and foam electrodes, i.e., to estimate the roughness factor as a ratio of $C(\text{DL})$ on foam and plates that have the same geometric area (1 cm × 1 cm). Notably, the double-layer capacitance ($C(\text{DL})$) extracted from the EIS data is 50 μF (see Figure 5), and it is in good agreement with the theoretical values assigned to 1 cm² of copper [49]. The capacitance of the double layer of a commercial foam, that has the same geometric area as a plate, is 7 to 14 times higher in comparison with a plate electrode. The thickness of the double electric layer is very small and is in tens of nanometers; therefore, this layer replicates the surface morphology on the nano-level, and the ratio with the value obtained on the plate electrode can represent the roughness

factor, and it matches the ratio of $C(DL)$ of both surfaces $-(C(DL_{\text{foam}}); C(DL_{\text{plate}}))$ is 7–14:1). However, the increase of double-layer capacitances with the increase of applied cathodic potential on both flat and porous surfaces is different. On the porous electrode, the $C(DL)$ increase is much higher when compared to the change in capacitances of the flat electrode. This increase is related to the much higher surface area, and the distribution of current on the surface of the foam. With higher potential, the current distributes more evenly on the whole foam surface, and the edge effect is less apparent, which also influences the surface area estimations [51,52].

When looking at the effect that the concentration of copper ions has on the EIS parameters (Table 3), we can divide the results into three sections: high concentration (0.2 M), mid-level concentrations (0.1 and 0.05 M), and low concentrations (0.01 M). The double electric layer (DL) capacitance values do not differ that much with the change of the concentration on both surface geometries. However, when looking at charge transfer resistance, the differences between concentrations are significant. At low concentrations, the charge transfer resistance is very high; this is caused by the lack of copper ions. In contrast, this resistance at mid-level concentrations is around 6–9 Ω , which depends on the surface geometry as well as applied potential (Figure 5). At high concentrations (0.2 M and higher), the charge transfer resistance values decrease approximately 3 times on both surfaces, because of an abundance of conducting particles. Nevertheless, this charge transfer resistance is lower at all investigated potentials and all concentrations on the foam electrode, showing that the reduction reaction occurs faster on the copper foams.

When taking a look at the charge transfer resistance dependence on potential (Figure 5) with both types of electrodes, it is clear that the 3D electrode displays approximately 1.5–1.7 times lower charge transfer resistance than the 2D electrode, agreeing with the results of voltammetry (see Figure 2). The differences in the charge transfer resistance on plate and foam electrodes are lower than the differences in the capacitances of DL, because the reaction layer is thicker than the DL, and in some areas of the foam electrode, it overlaps. As it can be seen from Figure 5, the difference between 2D and 3D electrodes in charge transfer resistance is higher at low potentials; thus, the charge transfer reaction on the foam occurs easier, and it partially explains the higher Cu deposition rate (see Table 2). However, lowering the charge transfer resistance, or in turn, the increase of the rate of the charge transfer reaction by approximately 2 times, does not result in increases in the Cu deposition rate by approximately 3 times.

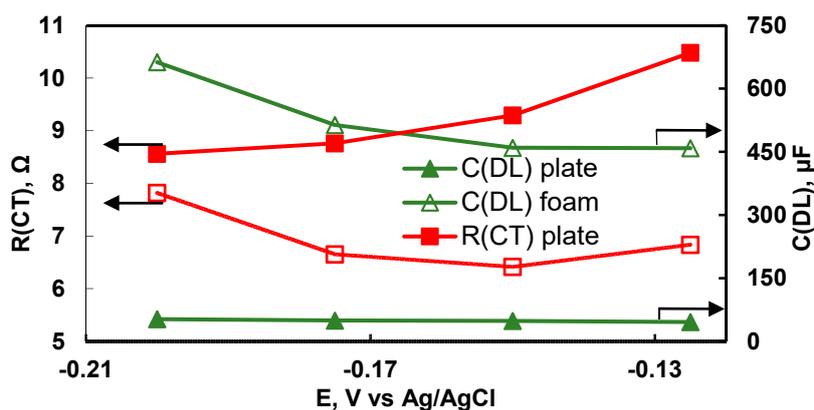


Figure 5. Dependence of double-layer capacitance (ordinate at the right) and charge transfer resistance (ordinate at the left) on potential applied for Cu plate and foam electrodes in 0.1 M CuSO_4 + 0.4 M Na_2SO_4 solution.

To further characterize the difference in copper deposition reactions on flat and porous copper surfaces, the components of EEC related to diffusion have been investigated in detail (Figure 6). The foam has lower charge transfer resistance, meaning faster reactions and better hydrodynamic qualities,

allowing for faster diffusion and in turn the much faster deposition, even with a larger surface and in turn, lower current density.

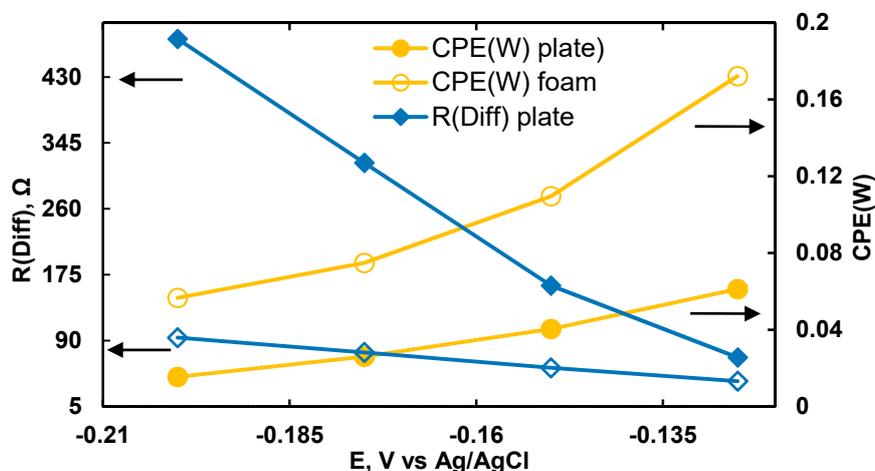


Figure 6. Dependence of diffusion-related elements of EEC on the potential applied. Measurements performed using a copper plate and copper foam as working electrodes in 0.1 M CuSO₄ + 0.4 M Na₂SO₄ solution.

Table 3. Values of electrochemical impedance spectroscopy (EIS) parameters obtained by fitting data obtained on copper foam and copper plates at −0.175 V versus Ag/AgCl at different copper concentrations. EC used for modeling shown in Figure 3 inset. CPE(DL): a double-layer (DL) capacitance modeled via the constant phase element (CPE), CPE(W): the capacitance caused by the concentration gradient, R(CT): charge transfer resistance, R(Diff): resistance caused by the concentration gradient.

Cu Plate	0.2 M CuSO ₄ + 0.3 M Na ₂ SO ₄	0.1 M CuSO ₄ + 0.4 M Na ₂ SO ₄	0.05 M CuSO ₄ + 0.45 M Na ₂ SO ₄	0.01 M CuSO ₄ + 0.49 M Na ₂ SO ₄
C(DL), μF	40.5	49.3	41.9	56.4
R(CT), Ω	2.98	8.76	7.44	54.66
CPE(W)	0.0696	0.0260	0.0285	0.00247
R(Diff), Ω	233.4	319.3	199.6	663.7
Cu Foam	–			
C(DL), μF	299.2	513.5	456.6	754.1
R(CT), Ω	2.39	6.65	6.74	122.20
CPE(W)	0.2033	0.0748	0.0668	0.0039
R(Diff), Ω	14.9	74.9	83.3	1551.0

The parameter related to diffusion CPE(W) at low concentrations is almost equal on both surface geometries, showing that the diffusion effect is similar, but the resistance at low concentration is about 2.5 times higher. It means that the diffusion layer is much thicker on the copper foams surface because of the porosity effect. Therefore, it causes a higher rate of copper electrodeposition. The overall trend in mid-level and high concentrations is that with the increase of Cu²⁺ concentration, the CPE(W) value increases, and the R(Diff) decreases. As it is seen from Table 3, the difference between R(Diff) values at 0.2 and 0.05 M concentrations on the flat surface is only around 14%, whereas on the foam electrode, the values of R(Diff) are lower, but all values are sensitive to the concentration of Cu(II) in the solution. The highest value of R(Diff) is obtained on the foam electrode at a relatively low concentration of Cu(II), i.e., 0.01 M, which is probably due to the faster depletion of copper ion concentration in the 3D diffusion layer and the necessity of a longer time to supply Cu(II) ions into the pores. Since the deposition rate on the foam electrode at a higher concentration of Cu(II) is 3 times faster than on the

flat electrode, this is mirrored by the behavior of $CPE(W)$, showing that the diffusion occurs 3 times faster on the foam. The efficiency of charge transfer on the porous surfaces is higher as well, which is in good agreement with other studies of metal depositions on porous surfaces [31].

To even better understand the diffusion peculiarities on 2D and 3D electrodes, the diffusion impedance using extracted values from total impedance data (presented in Table 4) was calculated. As it is shown in Figure 4, the copper deposition occurs under diffusion control at low frequencies (below 100 Hz) on both foam and plate electrodes, and diffusion is modeled by a parallel connection of $CPE(W)$ and $R(Diff)$ elements (see Figure 4). In this case, diffusion impedance, Z_{diff} , as a function of frequency is calculated by the equation:

$$Z_{diff}(\omega) = \frac{R_{Diff}}{1 + (j\omega)^\alpha Q R_{Diff}} \quad (1)$$

where Q and α are parameters of $CPE(W)$, $R(Diff)$ is resistance caused by diffusion, and ω is the phase angle ($\omega = 2\pi f$). However, when $\alpha = 1 - Q$ is pure capacitance, in our case, $\alpha = 0.5$, and the CPE represents diffusion [53].

The calculated diffusion impedance data are presented in Figure 7. As it is seen, the diffusion impedance on the plate Cu electrode is 2–4 times higher than that on the foam Cu electrodes, which is dependent on the frequency and potential applied.

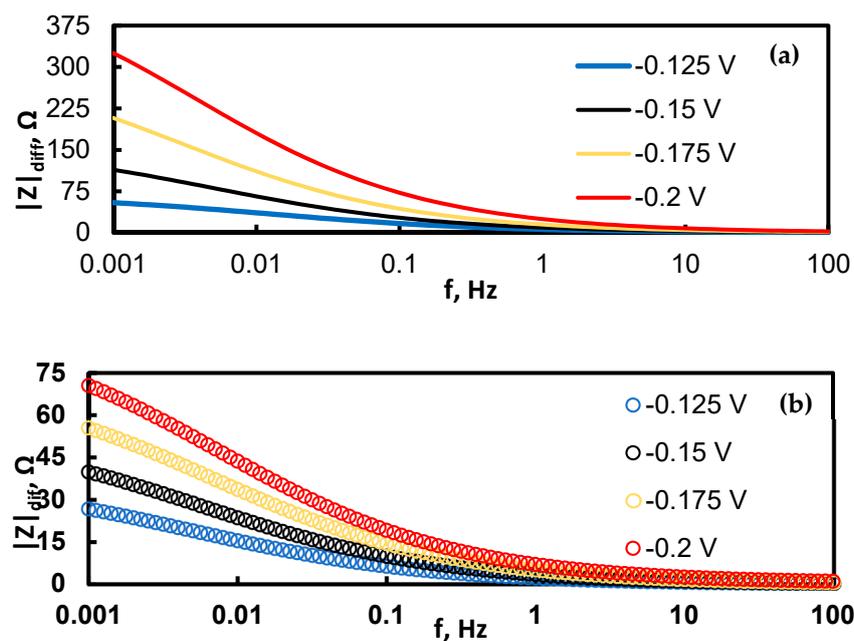


Figure 7. Bode plots of extracted diffusion impedance at various potentials on flat Cu substrate (a); and Cu foam substrate (b).

These results once again confirm the chronopotentiometric data obtained on both 2D and 3D Cu electrodes. For chronopotentiometry experiments, current values have been chosen higher than the limiting current values seen in Figure 8. In this case, the transition time at which the concentration of metal ions on the electrode becomes equal to zero is visual on the chronopotentiograms, and the effective diffusion coefficient can be calculated by the Sand equation:

$$i\sqrt{\tau} = \frac{nFAC_0\sqrt{\pi D_{eff}}}{2} \quad (2)$$

where τ is a transition time (s), i is a current (A), C_0 is the concentration of Cu(II) ions (mol/cm³), D_{eff} is the effective diffusion coefficient (cm²·s⁻¹), F is Faraday's constant, n is the number of electrons participating in the electrochemical reaction; and A is a geometrical surface area.

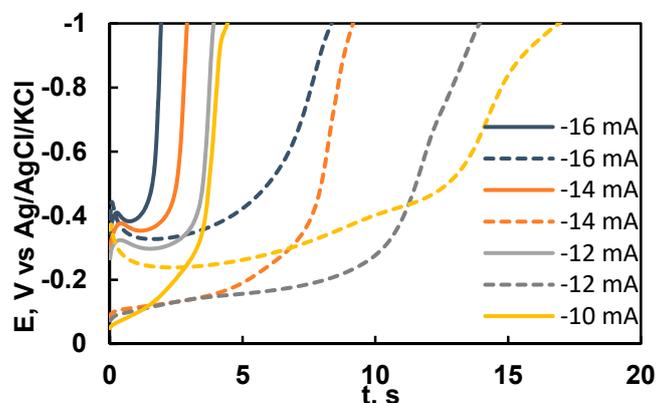


Figure 8. Chronopotentiograms on flat (continuous lines) and porous (dashed lines) electrodes at various current densities in 50 mM CuSO₄ and 0.45 M Na₂SO₄ solution. All the densities have been calculated for the geometrical area of the substrate of 1 cm².

In our case $i\sqrt{\tau} \sim \text{const}$, so the maximal deposition rate is controlled by the mass transfer. The values of the effective diffusion coefficient of Cu²⁺ ions on both plate and foam Cu electrodes were calculated by Equation (2), and the data are shown in Table 4. The effective diffusion coefficient on the plate electrode is almost three times lower than on the foam electrode, and it is in good agreement with EIS data.

Table 4. Effects of electrode geometry on effective Cu(II) ions diffusion coefficient.

Applied Current	Effective Diffusion Coefficient	
	Plate	Foam
$I, \text{ mA}$	$10^6 D, \text{ cm}^2 \cdot \text{s}^{-1}$	$10^6 D, \text{ cm}^2 \cdot \text{s}^{-1}$
-10	6.79	18.06
-12	6.72	19.70
-14	6.73	20.16
-16	6.62	20.77
Average D_{eff}	6.72	19.67

So, copper foams are great substrates for reactions that are either limited by the mass transfer (electrochemical depositions, etc.) or the ones that are restricted by adsorption or activation (HER and similar), making them great candidates to reduce the size of electrodes, but not to lose out on the efficiency and activity of electrodes.

4. Conclusions

A comprehensive investigation of the electrochemical deposition of copper onto 2D (plate) and 3D (foam) Cu substrates has been done. Using various electrochemical methods, it was determined that the rate-determining step in a copper deposition is diffusion. The main processes occurring on the electrode are the charge-up of double electric layer, charge transfer, and diffusion. The specific electrochemically active area of Cu foam was estimated from EIS data, and based on the values of the double electric layer, it was determined to be 7–14 times higher than that for the plate electrode. Based on the EIS data, it was determined that the charge transfer resistance on the Cu foam electrode is 1.5–1.7 times lower than that on the Cu plate electrode, which results in an increase in a charge transfer rate of

approximately 2 times. Based on the analysis of the diffusion impedance and chronopotentiometry data, it was found that Cu^{2+} mass transfer and the copper deposition rate is up to 3 times faster on the foam surface in comparison with a flat surface having the same geometric area in the same potential range. In addition, effective diffusion coefficients have been calculated from chronopotentiometry data using Sand's equation. These findings make Cu foam an attractive material for metal electrowinning processes as well as for processes controlled by adsorption (e.g., hydrogen evolution reaction).

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